

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S32	178	(substrate or wafer or semiconductor or workpiece) and (engager or holder) near3 pivot\$4 and shield	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/18 23:07
S47	237	(substrate or wafer or semiconductor or workpiece) near10 (engager or holder or finger or member) near6 (pivot\$4) near10 (vertical or upward or downward)	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/18 23:08
S46	736	(substrate or wafer or semiconductor or workpiece) same (engager or holder or finger or member) near6 (pivot\$4) near10 (vertical or upward or downward)	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/18 23:08
S48	204	(substrate or wafer or semiconductor or workpiece) near10 (engager or holder or finger or member) near6 (pivot\$4) near10 (vertical or upward or downward)	US-PGPUB; USPAT	OR	ON	2007/01/18 23:11
S50	18	"6167893"	US-PGPUB; USPAT	OR	ON	2007/01/19 11:32
S52	9	S51 not S50	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/19 11:35
S51	25	("4724619" "4788994" "5421056" "5445172" "5566466" "5666985" "5715610" "5775000" "5954072").PN. OR ("6167893"). URPN.	US-PGPUB; USPAT; USOCR	OR	ON	2007/01/19 11:35
S49	248	(substrate or wafer or semiconductor or workpiece) near10 (engager or holder or finger or member) near6 (pivot\$4) near10 (vertical\$3 or upward or downward)	US-PGPUB; USPAT	OR	ON	2007/01/19 11:38
S53	111	(substrate or wafer or semiconductor or workpiece) near10 (engag\$3 or holder or finger or member) near6 (pivot\$4) near10 (vertical\$3 or upward or downward) and (support or post or holder or engag\$3) near6 (fixed or immovable or stationary)	US-PGPUB; USPAT	OR	ON	2007/01/19 11:39